



PATENT
Atty. Dkt. AMAT/5335.Y1/CPI/COPPER/PJS

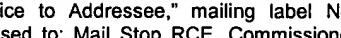
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on April 1, 2005 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV349852245US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

4/1/05 
Date Signature

INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/5335.Y1/KMT.

Respectfully submitted,



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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Application Number	10/625,480
Filing Date	July 22, 2003
First Named Inventor	Chen, et al.
Group Art Unit	2818
Examiner Name	Phuc T. Dang
Attorney Docket Number	AMAT/5335.Y1/CPI/COPPER/PJS

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Submission Date

April 1, 2005

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	A1	US-4486487	12/4/1984	Suntola, et al.	
	A2	US-5306666	4/26/1994	Izumi, et al.	
	A3	US-5374570	12/20/1994	Nasu, et al.	
	A4	US-5503875	4/2/1996	Imai, et al.	
	A5	US-5526244	6/11/1996	Bishop	
	A6	US-5711811	1/27/1998	Suntola, et al.	
	A7	US-5916365	6/29/1999	Sherman	
	A8	US-6015590	1/18/2000	Suntola, et al.	
	A9	US-6107208	8/22/2000	Cheng, et al.	
	A10	US-6139700	10/31/2000	Kang, et al.	
	A11	US-6174809	1/16/2001	Kang, et al.	
	A12	US-6197683	3/6/2001	Kang, et al.	
Examiner	A13	US-6200893	3/12/2001	Sneh	
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	A15	US-6207302	3/27/2001	Sugiura, et al.	
	A16	US-6207487	3/27/2001	Kim, et al.	
	A17	US-6270572	8/7/2001	Kim, et al.	
	A18	US-6284646	9/4/2001	Leem	
	A19	US-6287965	9/11/2001	Kang, et al.	
	A20	US-6305314	10/23/2001	Sneh, et al.	
	A21	US-6342277	1/29/2002	Sherman	
	A22	US-6348376	2/19/2002	Lim, et al.	
	A23	US-6358829	3/19/2002	Yoon, et al.	
	A24	US-6372598	4/16/2002	Kang, et al.	
	A25	US-6391785	5/21/2002	Satta, et al.	
	A26	US-6391803	5/21/2002	Kim, et al.	
	A27	US-6399491	6/4/2002	Jeon, et al.	
	A28	US-6416577	7/9/2002	Suntola, et al.	

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Filing Date	July 22, 2003
(Use as many sheets as necessary)		First Named Inventor	Chen, et al.
		Group Art Unit	2818
		Examiner Name	Phuc T. Dang
		Attorney Docket Number	AMAT/5335.Y1/CPI/COPPER/PJS
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		Submission Date	April 1, 2005

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		Number-Kind Code ² (if known)			
	A29	US-6416822	7/9/2002	Chiang, et al.	
	A30	US-6428859	8/6/2002	Chiang, et al.	
	A31	US-6451119	9/17/2002	Sneh, et al.	
	A32	US-6451695	9/17/2002	Sneh	
	A33	US-6458701	10/1/2002	Chae, et al.	
	A34	US-6468924	10/22/2002	Lee, et al.	
	A35	US-6475276	11/5/2002	Elers, et al.	
	A36	US-6475910	11/5/2002	Sneh	
	A37	US-6478872	11/12/2002	Chae, et al.	
	A38	US-6482733	11/19/2002	Raaijmakers, et al.	
	A39	US-6495461	12/17/2002	Tsubouchi, et al.	
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	A41	US-6534395	3/18/2003	Werkhoven, et al.	
	A42	US-6548424	4/15/2003	Putkonen	
	A43	US-6551929	4/22/2003	Kori, et al.	
	A44	US-6569501	5/27/2003	Chiang, et al.	
	A45	US-6596602	7/22/2003	Iizuka, et al.	
	A46	US-6596643	7/22/2003	Chen, et al.	
	A47	US-6599572	7/29/2003	Saanila, et al.	
	A48	US-6607976	8/19/2003	Chen, et al.	
	A49	US-6620670	9/16/2003	Song, et al.	
	A50	US-6620723	9/16/2003	Byun, et al.	
	A51	US-6630201	10/7/2003	Chiang, et al.	
	A52	US-6630413	10/7/2003	Todd	
	A53	US-6632279	10/14/2003	Ritala, et al.	
	A54	US-6660660	12/9/2003	Haukka, et al.	
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	A56	US-6803272	10/12/2004	Halliyal, et al.	

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Application Number

10/625,480

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July 22, 2003

First Named Inventor

Chen, et al.

Group Art Unit

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		Number-Kind Code ² (if known)			
	A57	US-20010000866	5/10/2001	Sneh, et al.	
	A58	US-20010002280	5/31/2001	Sneh	
	A59	US-20010009140	7/26/2001	Bondestam, et al.	
	A60	US-20010009695	7/26/2001	Saanila, et al.	
	A61	US-20010024387	9/27/2001	Raaijmakers, et al.	
	A62	US-20010024871	9/27/2001	Yagi	
	A63	US-20010028924	10/11/2001	Sherman	
	A64	US-20010034123	10/25/2001	Jeon, et al.	
	A65	US-20010041250	11/15/2001	Werkhoven, et al.	
	A66	US-20010050039	12/13/2001	Park, et al.	
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	A68	US-20020000598	1/3/2002	Kang, et al.	
	A69	US-20020007790	1/24/2002	Park	
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	A72	US-20020031618	3/14/2002	Sherman	
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	A76	US-20020052097	5/2/2002	Park	
	A77	US-20020060363	5/23/2002	Xi, et al.	
	A78	US-20020068458	6/6/2002	Chiang, et al.	
	A79	US-20020073924	6/20/2002	Chiang, et al.	
	A80	US-20020074588	6/20/2002	Lee	
	A81	US-20020076481	6/20/2002	Chiang, et al.	
	A82	US-20020076507	6/20/2002	Chiang, et al.	
	A83	US-20020076508	6/20/2002	Chiang, et al.	
	A84	US-20020081844	6/27/2002	Jeon, et al.	

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Application Number

10/625,480

Filing Date

July 22, 2003

First Named Inventor

Chen, et al.

Group Art Unit

2818

Examiner Name

Phuc T. Dang

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**INFORMATION DISCLOSURE
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U.S. PATENT DOCUMENTS

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		Number-Kind Code ² (if known)			
	A85	US-20020086111	7/4/2002	Byun, et al.	
	A86	US-20020086507	7/4/2002	Park, et al.	
	A87	US-20020094689	7/11/2002	Sandhu, et al.	
	A88	US-20020104481	7/18/2002	Bachhofer, et al.	
	A89	US-20020106536	8/8/2002	Lee, et al.	
	A90	US-20020117399	8/29/2002	Chen, et al.	
	A91	US-20020135071	9/26/2002	Kang, et al.	
	A92	US-20020144655	10/10/2002	Chiang, et al.	
	A93	US-20020144657	10/10/2002	Chiang, et al.	
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	A97	US-20020164421	11/7/2002	Chiang, et al.	
	A98	US-20020164423	11/7/2002	Chiang, et al.	
	A99	US-20020172768	11/21/2002	Endo, et al.	
	A100	US-20020177282	11/28/2002	Song	
	A101	US-20020182320	12/12/2002	Leskela, et al.	
	A102	US-20020187256	12/12/2002	Elers, et al.	
	A103	US-20020187631	12/12/2002	Kim, et al.	
	A104	US-20020197402	12/26/2002	Chiang, et al.	
	A105	US-20020197863	12/26/2002	Mak, et al.	
	A106	US-20030013300	1/16/2003	Byun	
	A107	US-20030013320	1/16/2003	Kim, et al.	
	A108	US-20030031807	2/13/2003	Elers, et al.	
	A109	US-20030032281	2/13/2003	Werkhoven, et al.	
	A110	US-20030042630	3/6/2003	Babcock, et al.	
	A111	US-20030049931	3/13/2003	Byun, et al.	
	A112	US-20030049942	3/13/2003	Haukka, et al.	

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Application Number

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	A113	US-20030054631	3/20/2003	Raaijmakers, et al.	
	A114	US-20030072884	4/17/2003	Zhang, et al.	
	A115	US-20030072975	4/17/2003	Shero, et al.	
	A116	US-20030082296	5/1/2003	Elers, et al.	
	A117	US-20030082300	5/1/2003	Todd, et al.	
	A118	US-20030082301	5/1/2003	Chen, et al.	
	A119	US-20030082307	5/1/2003	Chung, et al.	
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	A121	US-20030089942	5/15/2003	Bhattacharyya	
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	A133	US-20030160277	8/28/2003	Bhattacharyya	
	A134	US-20030165615	9/4/2003	Aaltonen, et al.	
	A135	US-20030166318	9/4/2003	Zheng, et al.	
	A136	US-20030168750	9/11/2003	Basceri, et al.	
	A137	US-20030172872	9/18/2003	Thakur, et al.	
	A138	US-20030173586	9/18/2003	Moriwaki, et al.	
	A139	US-20030185980	10/2/2003	Endo	
	A140	US-20030186495	10/2/2003	Saanila, et al.	

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A141		US-20030186561	10/2/2003	Law, et al.	
A142		US-20030189232	10/9/2003	Law, et al.	
A143		US-20030190423	10/9/2003	Yang, et al.	
A144		US-20030190497	10/9/2003	Yang, et al.	
A145		US-20030190804	10/9/2003	Glenn, et al.	
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A148		US-20030205729	11/6/2003	Basceri, et al.	
A149		US-20030213560	11/20/2003	Wang, et al.	
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Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
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B2		GB 2 355 727	5/2/2001	SAMSUNG ELECTRONICS CO., LTD		
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B5		JP 02-246161	10/1/1990	FUJITSU LTD		

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet

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of

9

Application Number

10/625,480

Filing Date

July 22, 2003

First Named Inventor

Chen, et al.

Group Art Unit

2818

Examiner Name

Phuc T. Dang

Attorney Docket Number

AMAT/5335.Y1/CPI/COPPER/PJS

Submission Date

April 1, 2005

FOREIGN PATENT DOCUMENTS

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		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
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Substitute for form 1449B/PTO		Application Number	10/625,480	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Filing Date	July 22, 2003	
		First Named Inventor	Chen, et al.	
		Group Art Unit	2818	
		Examiner Name	Phuc T. Dang	
		Attorney Docket Number	AMAT/5335.Y1/CPI/COPPER/PJS	
Sheet	8	of	9	Submission Date
April 1, 2005				

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		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
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	C1	George, et al. "Surface Chemistry for Atomic Layer Growth," J. Phys. Chem. 1996, 100, pp. 13121-13131	
	C2	Hwang, et al. "Nanometer-Size α -PbO ₂ -type TiO ₂ in Garnet: A Thermo barometer for Ultrahigh-Pressure Metamorphism," Science Vo. 288 (14 Apr 2000)	
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Sheet	9	of	9	Submission Date	April 1, 2005

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